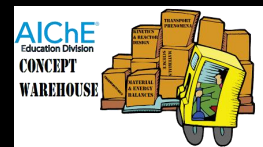


Engaging Engineering Students at Scale: Technological Innovation and Organizational Change



Milo Koretsky

Problem Solving: Procedural Approach

Given T

Step 1

Step 2

Step 3

Step 4

Find P

Example

Given T

Step 1

Step 2

Step 3

Step 4

Find P

Homework

Given P

Step 4

Step 3

Step 2

Step 1

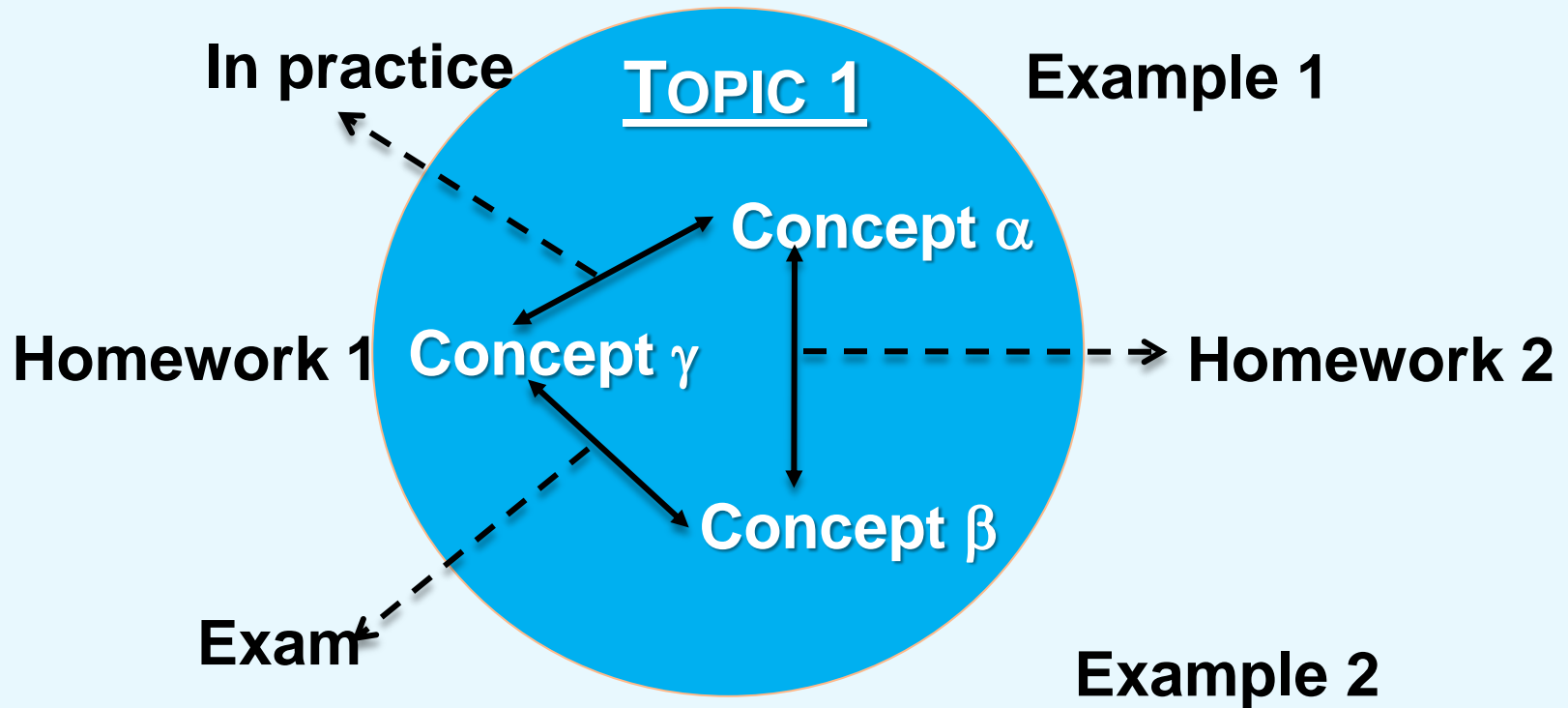
Find T

Exam

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Problem Solving: Conceptual Approach



Integrated Conceptual Knowledge Structure

Objective: To develop conceptual understanding by removing the “calculation procedure” from the question

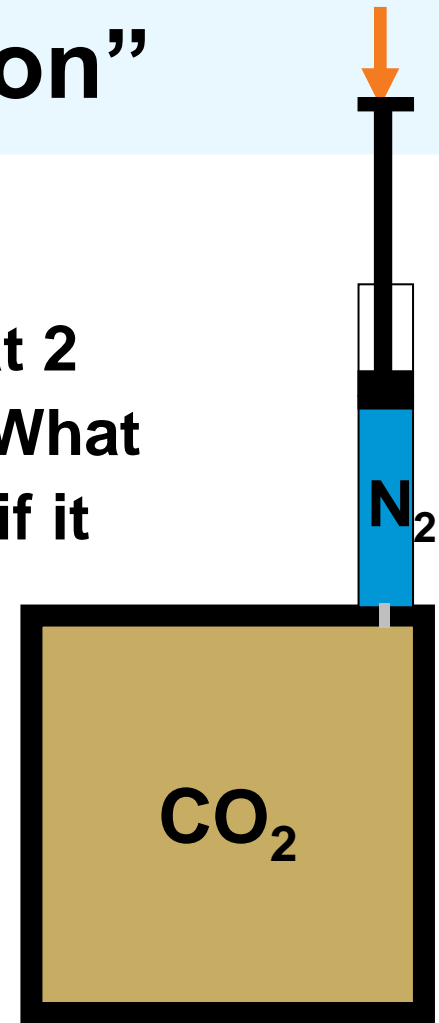
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Example “Concept Question”

A constant-volume tank contains CO_2 at 2 atm. Nitrogen is injected into the tank. What happens to the partial pressure of CO_2 if it all remains in the tank? Assume ideal gases and an isothermal system.

- 13 A. Decreases
- 32 B. Increases
- 6 C. Stays the same (chance is 17)



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Learning Landscape

Knowledge
Structures

Technology
Development



The AIChE Concept Warehouse

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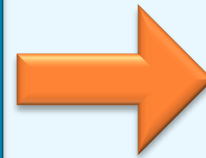


Peer Instruction

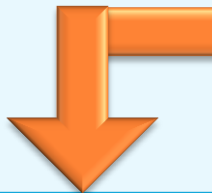
Instructor assigns a conceptual question



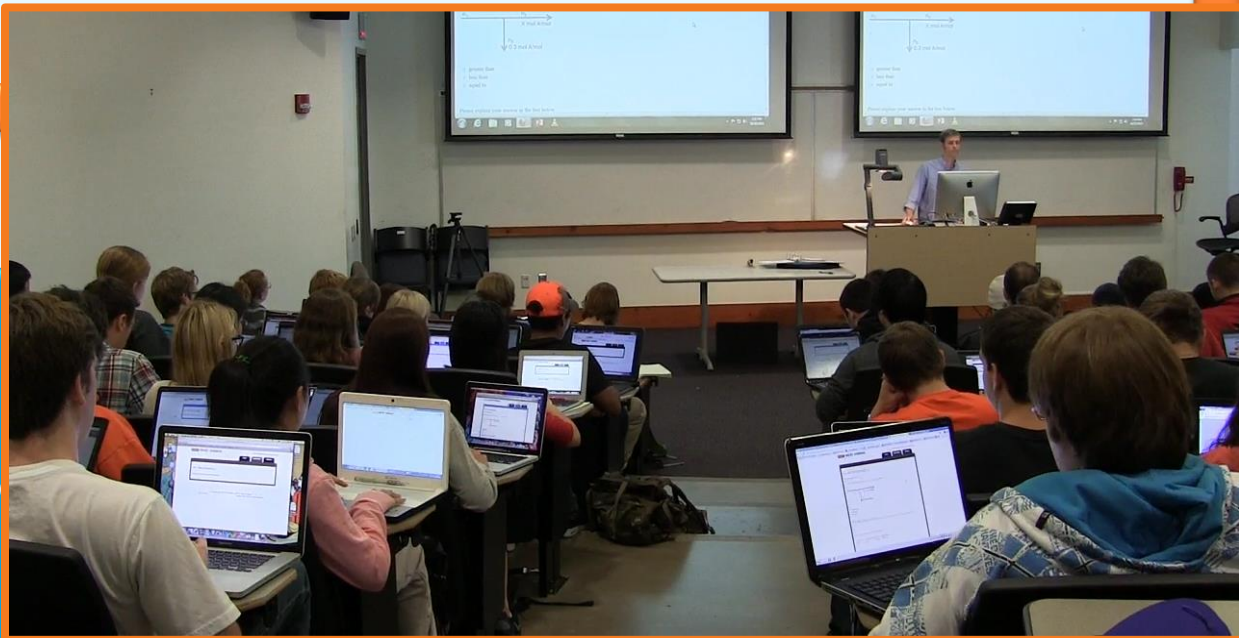
Students answer individually



Students discuss in groups



Instructor reassigns the question



Instructor reassigns the question



Learning Landscape

Knowledge Structures

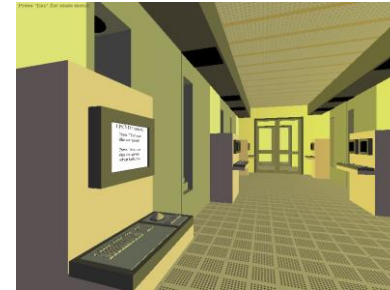


Disciplinary Practice

Industrially-Situated Labs

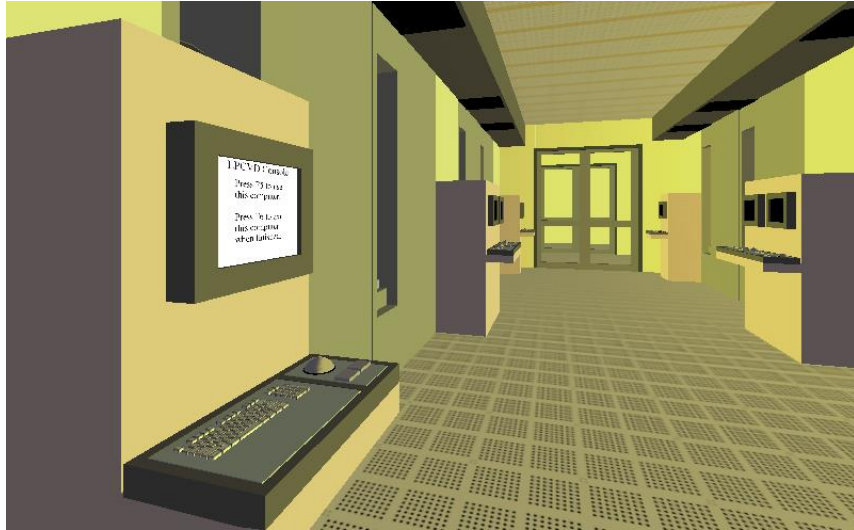
Technology Development

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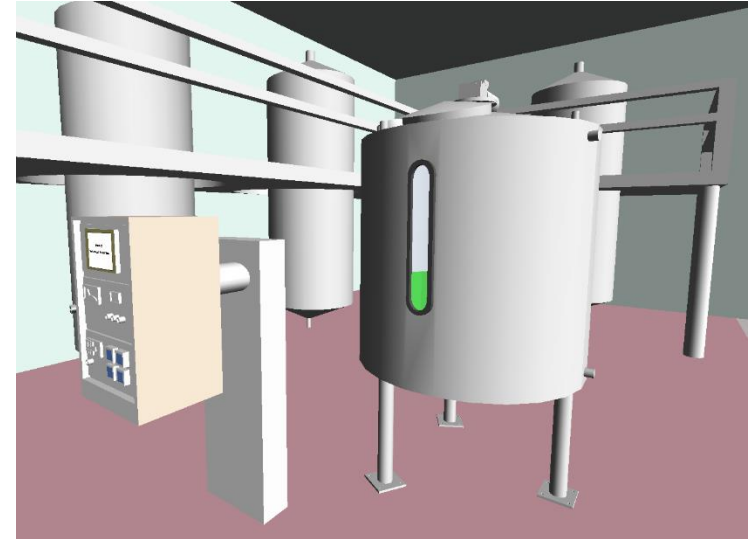


Virtual Process Development Tasks

Chemical Vapor Deposition Reactor

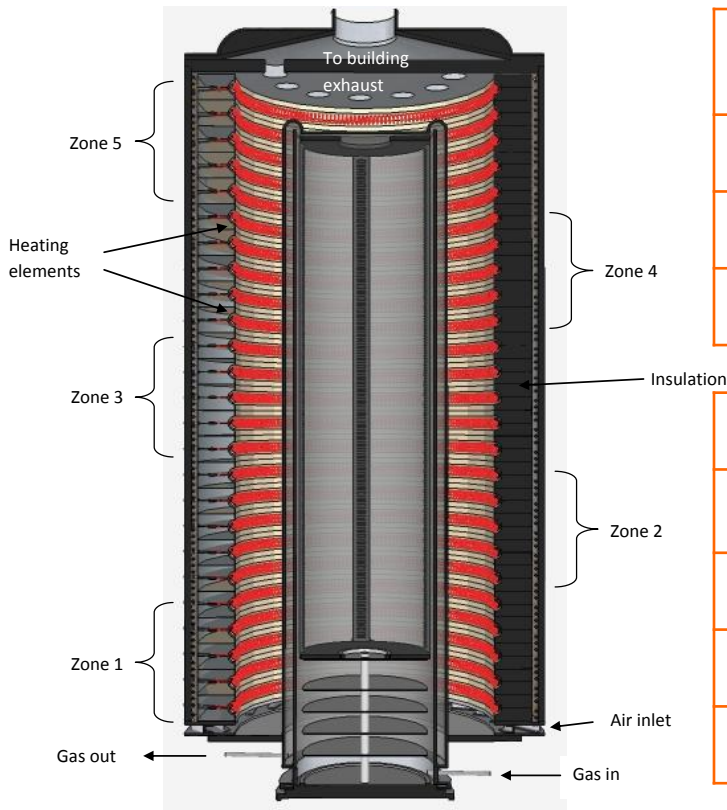


Bio Reactor



Virtual CVD Process Development Task

Students must develop a “recipe” to grow Si_3N_4 film with uniform thickness, by:



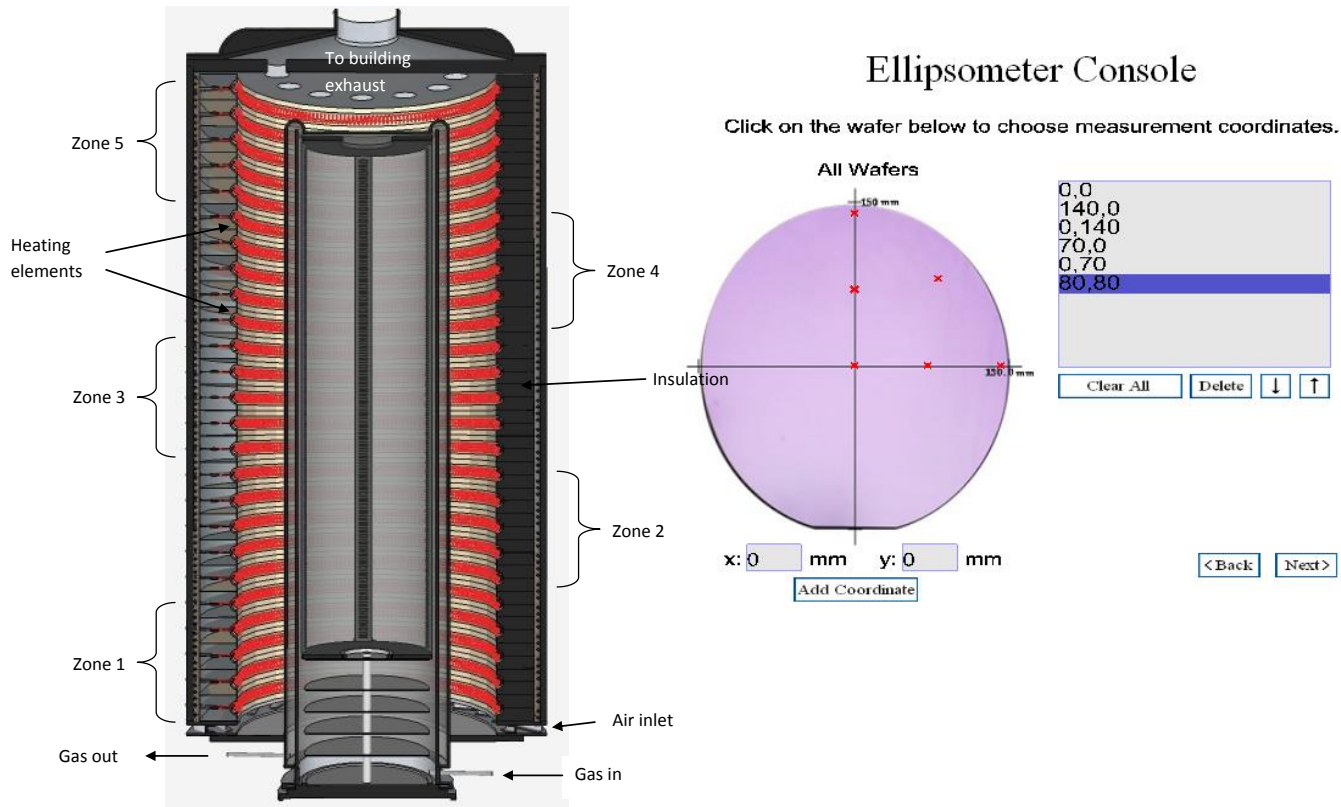
Pressure:		mTorr
NH₃ Flow:		sccm
DCS Flow:		sccm
Reaction time:		min

Zone 1:		°C
Zone 2:		°C
Zone 3:		°C
Zone 4:		°C
Zone 5:		°C

Choosing the 9 *Virtual CVD* Reactor parameters, and then

Virtual CVD Process Development Task

Students must develop a “recipe” to grow Si_3N_4 film with uniform thickness, by:



Choosing the locations on the wafer to measure

Each run and each measurement costs \$



Instructional Design

Deliverables

- Design Memo
- Initial parameters
 - Budget
 - Experimental strategy

Begin Experiments

- Update Memo
- Progress to date

- Final Report
- Final Oral Presentation
- Final Recipe
- Laboratory Notebook

Student-Coach Interaction

- Faculty Present
- Background info
 - Intro to software



- Design Meeting
- Discuss strategy
 - Students get authorization for VL



- Update Meeting
- Discuss progress & strategy



- Final Presentations
- 10-15 min present
 - 10-15 min questions from students, coach, 2 other faculty



Task Intro

End of Wk 1

End of Wk 2

End of Wk 3



Conceptions of Learning

“Students need to understand the concepts so they have the foundation to do engineering”

Doing



Understanding

or

“By doing engineering students can recognize the salient concepts they need to learn”

Understanding



Doing

Co-construction and Co-production

- Co-construction: cognitive talk directed at **making meaning**, trying to build connections between ideas and understanding, and answering how and why questions related to the knowledge underlying the task
- Co-production: cognitive talk orientated at the **completion of the set work** that was prescribed by the instructor (in School World) or develop the process recipe and meet engineering objectives of the project (in Engineering World).

Conceptions of Learning

“Students need to understand the concepts so they have the foundation to do engineering”

Production



Construction

or

“By doing engineering students can recognize the salient concepts they need to learn”

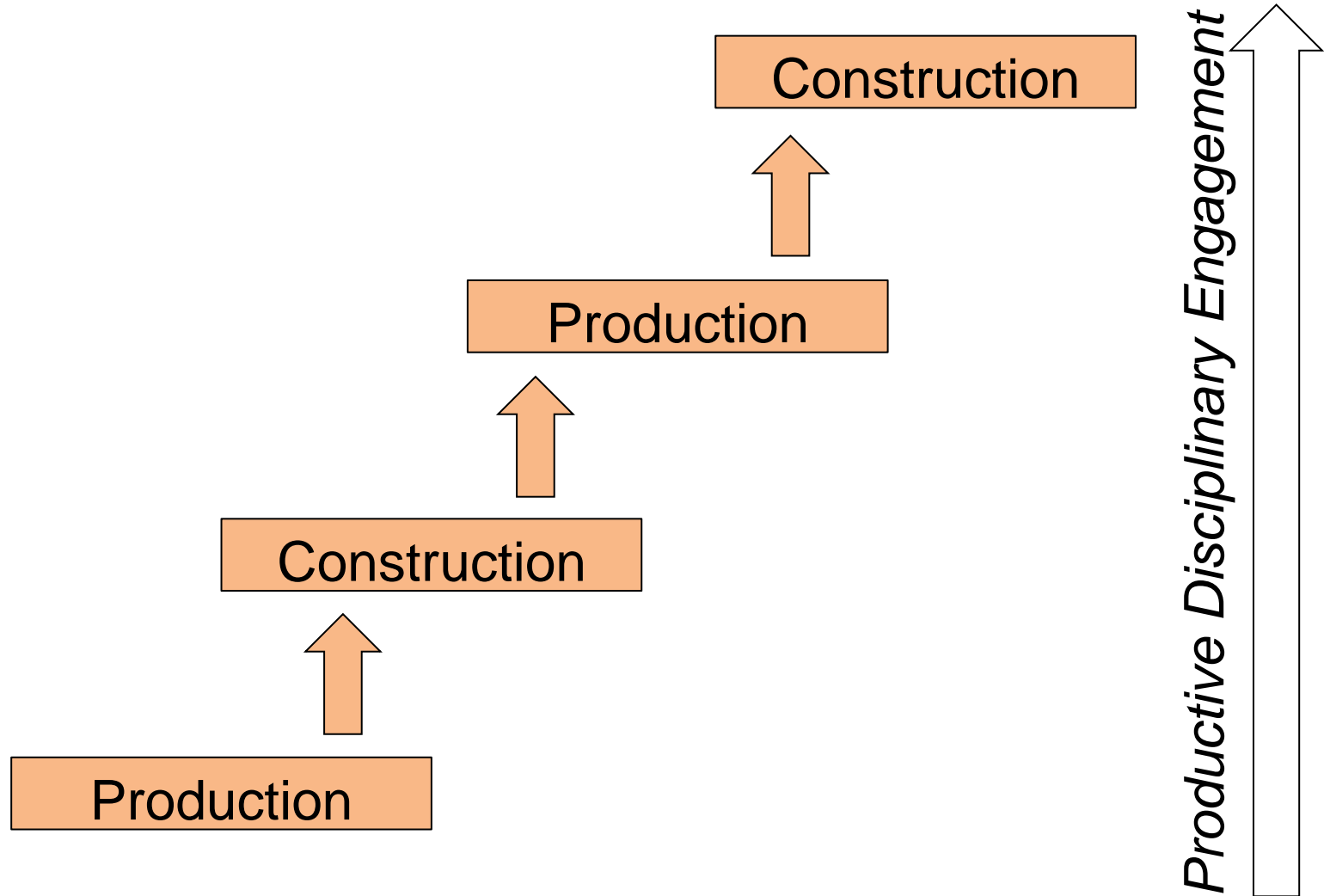
Construction



Production



Doing and Understanding in Authentic Engineering Projects





Learning Landscape

Knowledge Structures



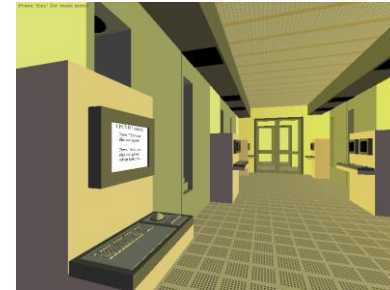
Disciplinary Practice

Industrially-Situated Labs

Technology Development



Organizational Change

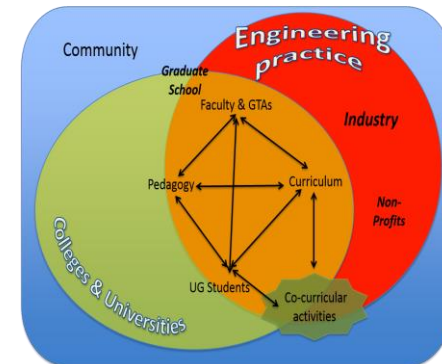


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Enhancing STEM Education at Oregon State University

Revolutionizing Engineering Dpts



Acknowledgements

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- *Concept Warehouse*: DUE - 1023099, DUE - 1245482, DUE - 1225456 (ASU Lead), DUE - 1225221 (Bucknell Lead)
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- *ESTEME@OSU*: DUE-1347817
- *Revolutionizing Engineering Departments*: EEC-1519467



□ Intel Faculty Fellowship Program

